

Express Mail No.: EV246529452US

PATENT  
H0005306

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Chien-Wei Li et al. Serial No.: Filed herewith Filing Date: Filed herewith For: SINTERED SILICON NITRIDE OF HIGH TOUGHNESS & GOOD HIGH TEMPERATURE PROPERTIES	
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**COMMENTARY RE INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

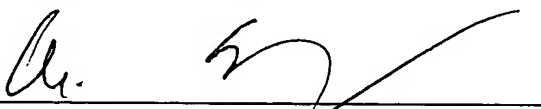
Dear Sir:

In accordance with 37 CFR §1.56, and in recognition of his duty to disclose to the United States Patent and Trademark Office relevant information known to be material to patentability, Applicant herewith submits a copy of the prior art listed on the attached Information Disclosure Statement (Form PTO-1449). The statement is not a representation that all of the information cited is necessarily effective as prior art against the application.

Applicant respectfully requests that the disclosed reference be made of record in the subject application.

Respectfully submitted,

Dated: July 15, 2003

  
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PTO/SB/08A (10-01)

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				Application Number		filed herewith
				Filing Date		filed herewith
				First Named Inventor		Chien-Wei Li et al.
				Group Art Unit		
				Examiner Name		
Sheet	1	of	2	Attorney Docket Number		H0005036

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
		Number – Kind Code <sup>2</sup> (if known)			
	1	US- 6261643 B1	07/17/2001	Hasz, et al.	
	2	US- 5914189	06/22/1999	Hasz, et al.	
	3	US- 5871820	02/16/1999	Hasz, et al.	
	4	US- 5851678	12/22/1998	Hasz, et al.	
	5	US- 5846460	12/08/1998	Matsuura, et al.	
	6	US- 5804523	09/08/1998	Oda, et al.	
	7	US- 5759933	06/02/1998	Li, et al.	
	8	US- 5702998	12/30/1997	Sugimoto, et al.	
	9	US- 5637540	06/10/1997	Li, et al.	
	10	US- 5494866	02/27/1996	Li	
	11	US- 5380179	01/10/1995	Nishimura, et al.	
	12	US- 5370832	12/06/1994	Sugimoto, et al.	
	13	US- 5364608	11/15/1994	Edler	
	14	US- 5312788	05/17/1994	Li, et al.	
	15	US- 5236786	08/17/1993	Newkirk, et al.	
	16	US- 5219500	06/15/1993	Yoshida, et al.	
	17	US- 5160508	11/03/1992	Pyzik, et al.	
	18	US- 5158914	10/27/1992	Hamazaki, et al.	
	19	US- 5118645	06/02/1992	Pyzik, et al.	
	20	US- 5100847	03/31/1992	Li, et al.	

FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite No. 1	Foreign Patent Document		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear	T6
		Country Code 3	Number 4 Kind Code 5 (if known)				

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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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		Number – Kind Code <sup>2</sup> (if known)			
	21	US- 5091347	02/25/1992	Pyzik, et al.	
	22	US- 5021372	06/04/1991	Pyzik, et al.	
	23	US- 4870036	09/26/1989	Yeh	
	24	US- 4716133	12/29/1987	Horiuchi, et al.	
	25	US- 4511402	04/16/1985	Miura, et al.	
	26	US- 4401768	08/30/1983	Morgan	
	27	US- 4332909	06//01/1982	Nishida, et al.	
	28	US- 4321310	03/23/1982	Ulion, et al.	
	29	US- 3833389	09/03/1974	Komeya, et al.	
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